Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	2766	((substrate or board or "printed circuit board" or pcb) and (chip or "intergrated circuit" or (semiconductor adj (chip or die)) or IC) and "heat sink" and (chamber or cavity) and (fluid or liquid or gas) and base)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 12:11
L2	6884	((substrate or board or "printed circuit board" or pcb) and (chip or "intergrated circuit" or (semiconductor adj (chip or die)) or IC) and "heat sink" and (chamber or cavity) and (fluid or liquid or gas) and base or "cold plate")	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 12:23
L3	210	2 and ("power convertor" or "power module")	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 12:15
L4	2873	((substrate or board or "printed circuit board" or pcb) and (chip or "intergrated circuit" or (semiconductor adj (chip or die)) or IC) and "heat sink" and (chamber or cavity) and (fluid or liquid or gas) and (base or "cold plate"))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 12:23
L5	116	4 and ("power module" or "power convertor")	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 12:24
S1	2085	361/700,698-699,703.ccls.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 06:05
S2	0	165/80.4,104.33	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 06:05
S 3	2779	165/80.4,104.33.ccls.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 06:06
S4	2011	257/714-715.ccls.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 06:06
S 5	2085	S1	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 06:06

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S6	3818	S1 S3	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 06:06
\$7	5009	S4 S6	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 06:06
S8	2847	S7 and (power module)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 06:07
S9	267	S8 and vapor same chamber	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 06:08
S10	10	("4019098" "4327399" "4519447" "4727455" "4833567" "4880053" "5199165" "5216580" "5769154" "6056044").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/10/06 06:17
S11	1	("6483705").URPN.	USPAT	OR	OFF	2005/10/06 06:21
S12	81	S8 and vapor adj chamber	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 06:25
S13	6034524	die or chip or semiconductor die or semiconductor chip or intergrated circuit	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 10:32
S14	6871839	substrate or board or printed circuit board or pcb	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 06:30
S15	3515636	heat sink	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 06:31
S16	2769820	chamber or cavity	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 06:33
S17	801535	condens\$3	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR .	ON	2005/10/06 06:33

\$18 \$19	45920 6377 5583	S13 same S14 same S15 same S16 S17 same S18	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB US-PGPUB; USPAT;	OR OR	ON	2005/10/06 06:36
S19		S17 same S18		OR	ON	
	5583		USOCR; EPO; JPO; DERWENT; IBM_TDB		OIN	2005/10/06 06:36
S20		S19 and (fluid liquid gas)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 06:37
S21	2646	S20 and seal\$3	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 06:40
S22	2673	S20 and (power module semiconductor power module invertor)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 06:47
S23	2710	S7 and (chamber cavity well)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 06:50
S24	951	S23 and condens\$3	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 07:03
S25	921	(361/699).CCLS.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/06 07:03
S26	5	("5262921" "5349498" "5455458" "5666269" "5978220").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/10/06 07:24
S27	1	("6473303").URPN.	USPAT	OR	OFF	2005/10/06 07:25
S28	4	("4323914" "4335781" "5185194" "5243223").PN.	US-PGPUB;	OR	OFF	2005/10/06 07:29
	•	(USPAT; USOCR		J.,	
S29	28	("5455458").URPN.	USPAT	OR	OFF	2005/10/06 07:30
S30	7	("3788393" "4652970" "4782893" "4805691" "5043845" "5046552" "5070936").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/10/06 07:42
S31	1	("4494171").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/10/06 07:45
S32	18	("5316075").URPN.	USPAT	OR	OFF	2005/10/06 07:54

S33	889	(361/700).CCLS.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/06 08:11
S34	168	(361/698).CCLS.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/06 08:15
S35	358	(361/703).CCLS.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/06 08:24
S36	1281	(165/80.4).CCLS.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/06 08:24
S 37	13	("2695753" "4019098" "4106557" "4327399" "4635709" "4949164" "5057909" "5131233" "5168919" "5305184" "5316077" "5413965").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/10/06 08:33
538	14	("5508884").URPN.	USPAT	OR	OFF	2005/10/06 08:33
S39	1	("3673306").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/10/06 08:38
S40	26	("4047198").URPN.	USPAT	OR	OFF	2005/10/06 08:40
S41	2346	165/104.33	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/06 08:40
S42	11	("4279292" "4326843" "4612978" "4758927" "5130498" "5213877" "5451279" "5473510" "5675474" "5926371" "5959840").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/10/06 08:53
S43	2	("6483185").URPN.	USPAT	OR	OFF	2005/10/06 09:17
S44	18	257/714-715	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/06 09:18
S45	2011	(257/714-715).CCLS.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/06 09:28
S46	34	(substrate and board and pcb and "circuit board" and die and chip and "intergrated circuit" and "semiconductor die" and IC and heat sink and (chamber or cavity) and vapor and condens\$3).clm.	US-PGPUB	OR	ON	2005/10/06 10:03
S47	0	(substrate and board and pcb and "circuit board" and die and chip and "intergrated circuit" and "semiconductor die" and IC and heat sink and (chamber or cavity) and vapor and condens\$3 and seal and "metal form").clm.	US-PGPUB	OR	ON	2005/10/06 09:46

S48	0	(substrate and board and pcb and "circuit board" and die and chip and "intergrated circuit" and "semiconductor die" and IC and heat sink and (chamber or cavity) and vapor and condens\$3 and seal and "metal foam").clm.	US-PGPUB	OR	ON	2005/10/06 09:47
549	0	(substrate and board and pcb and "circuit board" and die and chip and "intergrated circuit" and "semiconductor die" and IC and heat sink and (chamber or cavity) and vapor and condens\$3 and seal and "metal foam").cim.	US-PGPUB	OR	ON	2005/10/06 09:47
\$50	0	(substrate and board and pcb and "circuit board" and die and chip and "intergrated circuit" and "semiconductor die" and IC and heat sink and (chamber or cavity) and vapor and condens\$3 and seal and foam).clm.	US-PGPUB	OR	ON	2005/10/06 09:48
S51	0	(substrate and board and pcb and "circuit board" and die and chip and "intergrated circuit" and "semiconductor die" and IC and heat sink and (chamber or cavity) and vapor and condens\$3 and seal and foam).clm.	US-PGPUB	OR	ON	2005/10/06 09:48
S52	0	(substrate and board and pcb and "circuit board" and die and chip and "intergrated circuit" and "semiconductor die" and IC and heat sink and (chamber or cavity) and vapor and condensing and seal and foam).clm.	US-PGPUB	OR	ON	2005/10/06 09:49
S53	20632	(substrate and board and pcb and circuit board and die and chip and intergraded circuit and semiconductor die and IC and heat sink and (chamber or cavity) and vapor and condensing and seal and foam).clm.	US-PGPUB	OR	ON	2005/10/06 09:55
S54	31872	(substrate and board and pcb and circuit board and die and chip and intergraded circuit and semiconductor die and IC and heat sink and (chamber or cavity) and vapor and condensing and seal and metal foam).clm.	US-PGPUB	OR	ON	2005/10/06 09:56
S55	31872	(substrate and board and pcb and circuit board and die and chip and intergraded circuit and semiconductor die and IC and heat sink and(chamber or cavity)and vapor and condensing and seal and metal foam).clm.	US-PGPUB	OR	ON	2005/10/06 09:56
S56	11282	(substrate and board and pcb and "circuit board" and die and chip and "intergraded circuit" and "semiconductor die" and IC and heat adj sink and(chamber or cavity)and vapor and condensing and seal and metal foam).clm.	US-PGPUB	OR	ON	2005/10/06 09:58
S57	9	substrate and "semiconductor die" and "heat sink" and chamber and condens\$3.clm.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 10:06
S58	3	substrate and "semiconductor die" and "heat sink" and chamber and fluid and base and condens\$3.clm.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 10:07
\$59	3187393	(substrate or board or "printed circuit board" or "wiring board" or pcb and (chip or "intergrated circuit" or "semiconductor die" or IC "semicoductor chip") and "heat sink" and (chamber or cavity) and (fluid or liquid or gas) and base)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 10:54
S60	712774	S59 and (power module or invertor)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 10:44

S61	8549	S59 and ("power module" or invertor)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 10:46	
S62	1190322	S59 and power module	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 10:47	
S63	5706	S59 and "power module"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/06 11:55	